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APPLICANTS Takashi Shibayama, Kishima-gun, JAPAN; Yoshio Murakami, Saitama-shi, JAPAN; Takayuki Shingyoji, Saitama-shi, JAPAN;				
** COUNTRY DATA ***** This application is a 371 of PCT/JP03/02568 03/05/2003				
** FOREIGN APPLICATIONS ***** JAPAN 2002-261286 09/06/2002 JAPAN 2002-059182 03/05/2002				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met		STATE OR COUNTRY JAPAN	SHEETS DRAWING 8	TOTAL CLAIMS 5
Verified and Acknowledged Examiner's Signature <i>[Signature]</i> Initials <i>EH</i>	INDEPENDENT CLAIMS 1			
ADDRESS 00909				
TITLE Process for producing silicon single crystal layer and silicon single crystal layer				
FILING FEE RECEIVED 920	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	